



JPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77768

Takashi TAKIZAWA, et al.

Appln. No.: 10/714,639

Group Art Unit: 2855

Confirmation No.: 3272

Examiner: Jermaine L. JENKINS

Filed: November 18, 2003

For: SEMICONDUCTOR PRESSURE SENSOR

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the *Office Action* dated December 29, 2005, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	16